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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Hiroyuki Ikeda Atty. Docket No. 075834.00064
Serial No.: 09/ 821,636 Group Art Unit: 2811
Filed: March 29, 2001 Examiner: Thien F. Tran
Invention: "THIN FILM SEMICONDUCTOR APPARATUS AND METHOD FOR DERIVING THE SAME"

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RESPONSE TO ELECTION/RESTRICTION REQUIREMENT

Assistant Commissioner of Patents
Washington, D.C. 20231

SIR:

In response to the Office Action dated June 7, 2002, Applicant elects claims 1-19 of Invention I drawn to a semiconductor device and Embodiment 1 of Fig. 1, drawn to a thin film semiconductor device. Applicant specifically reserves the right to prosecute the non-elected claims in a later filed continuation or divisional application.

Applicant therefore awaits consideration and examination of elected claims 1-19 and respectfully requests consideration on the merits in due course.

NEW ATTORNEY OF RECORD

Applicant has concurrently submitted herewith a Revocation and Substitute Power of Attorney document that has been executed and requests that all future correspondence be directed to the attention of the undersigned.

Respectfully submitted,

Date: July 8, 2002

(Reg. #37,607)

Robert J. Depke

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55 West Monroe Street, Suite 800

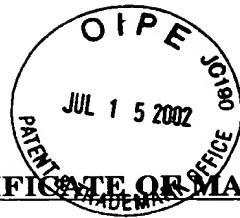
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Attorney for Applicant

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CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to:

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DATE: July 8, 2002


Attorney for Applicant

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